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Approximately 80 results found in the Worldwide database for:
 piezoelectric in the title AND bonding and (bend* or flex*) in the title or abstract
 (Results are sorted by date of upload in database)

Multi-Layer Piezoelectric Element and Method for Manufacturing the Same

Inventor: KONDO MITSUO (JP); TERAZONO KYOCERA CORP (JP)

MASAKI (JP); (+2)

EP: H01L41/047; H01L41/083

(IPC: H01L41/083; F02M51/00; F02M51/06

(+11)

Publication info: US2007278907 - 2007-12-06

Large dimension, flexible piezoelectric ceramic tapes and methods to make same

Inventor: XU BAOMIN (US); BUHLER STEVEN A XEROX CORP (US)

(US); (+5)

EP: B06B1/06C3; G01L1/16; (+2)

(IPC: H01L27/20; H01L41/09; B06B1/06

(+17)

Publication info: EP1808896 - 2007-07-18

High sensitivity, low noise piezoelectric flexural sensing structure

Inventor: ZOU LICHUN (US); DENG KEN K (US) Applicant:

EP: G01P15/09D

(IPC: G01B7/16; G01B7/16

Publication info: US2007119259 - 2007-05-31

Electroding of ceramic piezoelectric transducers

Inventor: GAILUS DAVID W (US); HOISINGTON DIMATIX INC (US)

PAUL A (US)

EP: B41J2/14D; B41J2/16D; (+1)

(IPC: H01L41/047; B41J2/14; H01L41/00

(+1)

Publication info: EP1667243 - 2006-06-07

PIEZOELECTRIC ELECTROACOUSTIC TRANSDUCER

Inventor: TAKESHIMA TETSUO (JP); YAMAUCHI MURATA MANUFACTURING CO (JP);

MASAKAZU (JP); (+2)

TAKESHIMA TETSUO (JP); (+3)

EP: H04R17/00; G10K9/125

(IPC: (IPC1-7): H04R17/00; G10K9/122;

H01L41/08

Publication info: WO2006025138 - 2006-03-09

HIGH SENSITIVITY, LOW NOISE PIEZOELECTRIC FLEXURAL SENSING STRUCTURE

Inventor: ZOU LICHUN (US); DENG KEN KAN WILCOXON RES INC (US); ZOU

(US)

LICHUN (US); (+1)

EP:

(IPC: G01B5/28; G01B5/28; G01C (+1)

Publication info: WO2005059472 - 2005-06-30

High sensitivity, low noise piezoelectric flexural sensing structure

Inventor: ZOU LICHUN (US); DENG KEN K (US) Applicant:

IPC: G01L1/16; G01L1/04C; (+1)

IPC: G01B5/28; G01L1/04; G01L1/16 (+6)

Publication info: US2005132816 - 2005-06-23

SINGLE CRYSTAL PIEZOELECTRIC APPARATUS AND METHOD OF FORMING SAME

Inventor: CLINGMAN DAN J; JACOT A DEAN

Applicant: BOEING CO (US)

IPC: B32B37/14B; B32B38/18D; (+3)

IPC: B32B37/14; H01L41/09; H01L41/113

(+8)

Publication info: WO2005001950 - 2005-01-06

Piezoelectric acoustic transducer

Inventor: YOKOI YUKO (JP); TAJIMA KIYOTAKA (JP); (+1)

Applicant: MURATA MANUFACTURING CO (JP)

IPC: H04R17/00

IPC: H04R17/00; G10K9/122; H01L41/083

(+4)

Publication info: US2004201326 - 2004-10-14

PIEZOELECTRIC OSCILLATION GYROSCOPIC ELEMENT AND SENSOR

Inventor: KIKUSHIMA MASAYUKI

Applicant: SEIKO EPSON CORP

IPC:

IPC: G01P9/04; G01C19/56; G01P9/04 (+3)

Publication info: JP2005106481 - 2005-04-21

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